

# MNC 2019 - 32nd International Microprocesses and Nanotechnology Conference

## Veranstaltung - MNC 2019 - 32nd International Microprocesses and Nanotechnology Conference

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| <b>Titel</b> | MNC 2019 - 32nd International Microprocesses and Nanotechnology Conference |
| <b>Wann</b>  | Mo, 28. Oktober 2019 - Do, 31. Oktober 2019                                |

## Beschreibung

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MNC 2019 - 32nd International Microprocesses and Nanotechnology Conference

The MNC conference is in its 32nd year and is intended to provide a forum for discussing lithography science and process technology using photon, electron, ion, other energetic particles and nanomaterials. This conference covers applications to micro-and nano-structure fabrication and related physics and devices and also their fusion applications with other fields like bio, medical information, and communication technology.

Following topics are planned:

### SCOPE

#### **1.Lithography and Related Technologies and Metrology**

- 1-1: Photolithography and Patterning
- 1-2: Electron and Ion Beam Technologies
- 1-3: Resist and Directed Self-Assembly

#### **2:Nanotechnology**

- 2-1: Nanocarbons
- 2-2: Nanodevices
- 2-3: Nanofabrication
- 2-4: Inorganic Nanomaterials
- 2-5: Organic Nanomaterials
- 2-6: NanoTool

#### **3: Nanoimprint, Hybrid-NIL, Biomimetics, and Functional Surfaces**

#### **4: BioMEMS, Lab on a Chip, and Nanobiotechnology**

#### **5: Microsystem Technology and MEMS**

Symp. Recent Progress of Atomic Layer Processing (ALP) Technology

Please learn more about this event by visiting following website:

<http://imnc.jp/>

## Lokalität - Hiroshima

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|-----------------|---------------------------|
| <b>Standort</b> | <a href="#">Hiroshima</a> |
| <b>Ortsname</b> | Japan                     |
| <b>Land</b>     | JP                        |